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RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2876

00862.022319

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Ken MATSUMOTO) : Examiner: L. M. Caputo
Application No.: 09/920,752) : Group Art Unit: 2876
Filed: August 3, 2001) : Confirmation No.: 5950
For: SUBSTRATE TRANSFER APPARATUS,)
SEMICONDUCTOR MANUFACTURING)
APPARATUS, AND SEMICONDUCTOR) June 28, 2004
DEVICE MANUFACTURING METHOD) (Monday)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated April 26, 2004, the time for response being extended from Saturday, June 26, 2004 to Monday, June 28, 2004, please amend the above-identified application as follows, pursuant to 37 C.F.R. § 1.116: